Search Notes			

Application No.	Applicant(s)
09/751,083	CAMPBELL ET AL.
Examiner	Art Unit
Rodney E Fuller	2851

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	SEARCHED				
Class	Subclass	Date	Examiner		
356	237.1 237.2 237.5 * 600 630 632	3/15/2004	REF		
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Class	Subclass	Date	Examiner	
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SEARCH NOT (INCLUDING SEARCH	'ES Strategy)
	DATE	EXMR
East: furnace or oven + film thickness + multi-zone + temperature + deposition rate + wafer	3/15/2004	REF
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